Search Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination
10/611,365	WANG ET AL.
Examiner	Art Unit
Mellissa M. Chojnacki	2164

SEARCHED			
Class	Subclass	Date	Examiner
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INTERFERENCE SEARCHED				
Class	Subclass	Date ⁻	Examiner	
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Searched EAST, USPTO, JPO, EPO, IBM_TDB, PGPUB, Strategy enclosed.	12/22/2006	MMC
Consulted Examiner Neveen-Abel-Jalil and Primary Examiner Sam Rimell regarding art and office action.	12/22/2006	ммс
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